

RESPONSE UNDER 37 C.F.R. § 1.116 **EXPEDITED PROCEDURE - EXAMINING GROUP 2800**

PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/075,640

Confirmation No. : 9841

Applicant: Michael Nuttall and Garry Anthony Mercaldi

Filed : February 13, 2002

Attorney Docket No.: 500803.02

Art Unit : 2818 Customer No.

: 27,076

Examiner : David Vu

Title

: METHOD FOR ENHANCING VERTICAL GROWTH DURING THE SELECTIVE

FORMATION OF SILICON, AND STRUCTURES FORMED USING SAME

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450



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Sir:

Applicants acknowledge receipt of the Office Action dated May 16, 2006.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.